

PTO/SB/08A (07-06)

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 1 of 2

Complete if Known

Application Number	10/579,511
Filing Date	30 May 2007
First Named Inventor	Torbojrn Sandstrom
Art Unit	1756
Examiner Name	Unassigned
Attorney Docket Number	MLSE 1060-1

U. S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	A1	US- 4,822,975	04-18-1989	Torigoe	
	A2	US- 4,970,546	11-13-1990	Suzuki et al.	
	A3	US- 4,879,605	11-07-1989	Warkentin et al.	
	A4	US- 5,103,101	04-07-1992	Berglund et al.	
	A5	US- 6,717,650	04-06-2004	Jain	
	A6	US- 5,340,700	08-23-1994	Chen et al.	
	A7	US- 4,989,255	01-29-1991	Manns et al.	
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ Number ⁴ Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
	B1	JP 02135723 A2	05-24-1990	Nikon Corp.	Abstract only	
	B2	JP 03179357 A2	08-05-1991	Nikon Corp.	Abstract only	
	B3	WO 0193303 A2	12-06-2001	Chabala et al.		
	B4	WO 03079111 A1	09-25-2003	Tyrell et al.		
	B5	EP 1324137 A2	07-02-2003	ASML Netherlands B.V.		

Examiner Signature	/Brittany Raymond/	Date Considered	09/28/2010
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First Named Inventor	Torbjorn Sandstrom
Art Unit	1756
Examiner Name	Unassigned
Attorney Docket Number	MLSE 1060-1

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	C1	PCT International Search Report and Written Opinion of the International Searching Authority for International Application No. PCT/SE2004/001701 (filed 19 November 2004), mailed 11 March 2005.	
	C2	PCT International Search Report for International Application No. PCT/SE2004/001700 (filed 19 November 2004), mailed 02 May 2005.	
	C3	MCCARTHY, A. M. et al. "A Novel Technique for Detecting Lithographic Defects," IEEE Transactions on Semiconductor Manufacturing, Vol. 1, No. 1 p.10-15 (Feb. 1998).	
	C4	NEWMAN, T. et al. "Evaluation of OPC Mask Printing with a Raster Scan Pattern Generator," Proceedings of SPIE, Vol. 4691, Optical Microlithography XV, p.1320-1330 (July 2002).	
	C5	Rieger, M. L. et al. "Lithographic Alternatives to PSM Repair," Proceedings of SPIE, Vol. 1674, Optical/Laser Microlithography V, p.609-617 (1992).	
	C6	Rieger, M. L. et al. "Image Quality Enhancements for Raster Scan Lithography," Proceedings of SPIE, Vol. 922, Optical/Laser Microlithography, p. 55-64 (March 1988).	
	C7	Stephanakis, A. C. et al. "Advances in 1 : 1 Optical Lithography," Proceedings of SPIE, Optical Microlithography VI, Vol. 772, p.74-85 (1987).	
	C8	WOLF, S. "Advanced Lithography," p.493-513 in Silicon Processing for the VLSI Era, Vol.1 - Process Technology, Lattice Press, Inc. (1986).	

Examiner Signature	/Brittany Raymond/	Date Considered	09/28/2010
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